

Docket No.: 55071-329



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
Douglas VAN DEN BROEKE, et al.	:	Confirmation Number: 3769
	:	
Application No.: 10/756,830	:	Group Art Unit: 2891
	:	
Filed: January 14, 2004	:	Examiner: Caridad EVERHART
	:	

For: METHOD AND APPARATUS FOR PROVIDING OPTICAL PROXIMITY FEATURES  
TO A RETICLE PATTERN FOR DEEP SUB-WAVELENGTH OPTICAL LITHOGRAPHY

**RESPONSE UNDER 37 C.F.R. § 1.111**

Mail Stop – Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action dated April 12, 2005, having a shortened statutory period for response set to expire July 12, 2005, a petition for a one month extension of time up to and including August 12, 2005 being filed concurrently herewith, Applicants respectfully request reconsideration of the pending rejections for the reasons set forth below.